

STEIN, MCEWEN & BUI LLP

Telephone
(202) 216-9505

1400 Eye Street, N.W.
Suite 300
Washington, D.C. 20005

RECEIVED
CENTRAL FAX CENTER

DEC 07 2004

Facsimile
(202) 216-9510

FACSIMILE TRANSMISSION

December 7, 2004

TO (FIRM): United States Patent And Trademark Office, Group Art Unit: 2653
ATTN: Examiner: Kim Kwuk Chu

FAX NO.: 703-872-9306

TELEPHONE:

FROM: James G. McEwen

Re: U.S. Patent Application
Serial No.: 09/898,201
For: OPTICAL PICKUP WITH IMPROVED COLLIMATING LENS FOR USE WITH
LONG AND SHORT WAVELENGTH LASER BEAMS *
Inventor: Tae-kyung KIM, et al.
Our Docket: 1293.1144

NO. OF PAGES (Including this Cover Sheet) 6

PRIVILEGED & CONFIDENTIAL

The information contained in this communication is confidential, may be attorney-client privileged, and is intended only for the use of the addressee(s). Unauthorized use, disclosure or copying is strictly prohibited. If there are any problems with this transmission, please contact us immediately.

COMMENTS:

RESPONSE AND REQUEST FOR RECONSIDERATION
UNDER 37 C.F.R. §1.116
**** EXPEDITED PROCEDURE ****

CERTIFICATE OF FACSIMILE TRANSMISSION
I hereby certify that this correspondence is being
transmitted via facsimile to: Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450
on DEC 7 2004
By: STEIN, McEWEN & BUI LLP
Date: Dec 7, 2004

Docket No. 1293.1144

**RESPONSE AND REQUEST FOR RECONSIDERATION
UNDER 37 C.F.R. §1.116**

**** EXPEDITED PROCEDURE ****

**RECEIVED
CENTRAL FAX CENTER**

DEC 07 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Tae-kyung KIM, et al.

Application No.: 09/698,201

Group Art Unit: 2653

Confirmation No. 6730

Filed: October 30, 2000

Examiner: Kim Kwuk Chu

For: OPTICAL PICKUP WITH IMPROVED COLLIMATING LENS FOR USE WITH LONG
AND SHORT WAVELENGTH LASER BEAMS

MAIL STOP AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This is responsive to the Final Office Action mailed September 15, 2004, having a
shortened period for response set to expire on December 15, 2004.

The following remarks are respectfully submitted.